| INFORMATION DISCLOSURE CITATION (Use several sheets if necessary) PTO Form 1449 | | | Attorney Docket No. 053785-5158 | | } | Application No.: 10/695,897 | | | |
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| | | | Applicant: Seok-Woo LEE | | | | | | |
| | | | Filing Date: October 30, 2003 | | Grou | Group Art Unit: 2822 | | | |
| | | U.S. | PATENT DOCUMEN | rs | | | | <u>.</u> | |
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| | Document Number | Date | Country | Class | Sub Class | | Transl: YES | ation NC | |
| MC | 2001-0052812 | 06/25/2001 | Korea | | | Abs | Abstract | | |
| MG | 11-074536 | 03/16/1999 | Japan | Japan Abstract | | tract | | | |
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| THER DOCUM | ENTS (Including Aut | hor, Title, Date, P | ertinent Pages, Etc.) | . 1 | | | | | |
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in conformance and not considered. Include copy of this form with next communication to applicant.

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Attorney Docket No. Serial No. Unassigned 10/695,897 053785-5158 INFORMATION DISCLOSURE CITATION (Use several sheets if necessary) Applicants Seok-Woo LEE PTO Form 1449 Filing Date Group Unassigned 2822 October 30, 2003 **U.S. PATENT DOCUMENTS** *Examiner Document Sub Initial Number Date Name Class Class Filing Date **FOREIGN PATENT DOCUMENTS** Document Sub **Translation** Number Class Date Country Class YES NO OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.) S. MATSUDA, et al. "Novel Corner Rounding Process For Shallow Trench Isolation Utilizing MSTS MG (Micro-Structure Transformation of Silicon)." IEDM Technical Digest. pp. 137-140, 1998. Examiner Date Considered Maria Guluero Mana Gululo (0-/0-05

Initial if reference considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.